



Agent Docket No.: Stanford: Schaper MxL 01

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of)
Charles D. Schaper)
Application No: 09/ 898,521)
Filed : July 3, 2001)
Title: **Molecular Transfer Lithography**)
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Palo Alto, California
April 4, 2002

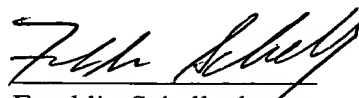
Assistant Commissioner for Patents
United States Patent Office
Washington DC 20231

REVISED FORMAT OF FIRST PRELIMINARY AMENDMENT

Sir:

The Version with Markings to Show Changes of the preliminary amendment submitted September 25, 2001, although comporting to 37 CFR 1.121(b)(1)(iii), did not use the format of brackets and underlining now present in the January 2002 edition of the Patent Rules. Please accept the following sheet, which comports to this format, for use as needed.

Respectfully submitted,


Franklin Schellenberg
Registration No. 47,315



BOX AMENDMENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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TRANSMITTAL LETTER

Palo Alto, California 94306
April 4, 2002

TO THE COMMISSIONER FOR PATENTS:

Transmitted herewith for filing under 37 C.F.R. § 1.53(b) by Express Mail are the following Application parts related to the patent application of Charles D. Schaper, assigned an application number 09 / 898,521 and entitled MOLECULAR TRANSFER LITHOGRAPHY.

- X 1. A Preliminary Amendment is enclosed.
- X 2. A Drawing is enclosed.
- X 3. A communication concerning a previous Preliminary Amendment is enclosed.

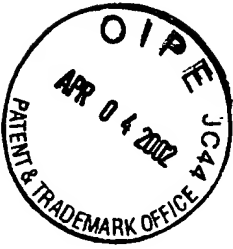
In the Specification

RELATED INVENTIONS

This application relates to, claims the benefit of the filing date of, and incorporates by reference the United States provisional patent applications entitled “Micro-Transfer Lithography”, # [XX/XXXXXX] 60/273,055, filed [Feb. 12,] March 5, 2001, “Production of Integrated Circuit Patterns using Micro-Transfer Lithography via Intermediary Substrate”, # [YY/YYYYYY] 60/ 273,535, filed Mar. [4] 7, 2001, and “Molecular Transfer Lithography”, # [ZZ/ZZZZZZ]. 60/ 277,578, filed Mar. [16] 22, 2001, which are all assigned to the assignee of the present invention.

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Respectfully submitted,

Franklin Schellenberg
Registration No. 47,315
Day: 408-487-7082
Eve: 650-856-3975

EXPRESS MAIL CERTIFICATE

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Franklin Schellenberg
(Typed or printed name of person mailing paper or fee)

Franklin Schellenberg 4/4/2002
(Signature of person mailing paper or fee)